## PATENT APPLICATION

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Docket No: Q87929 In re application of Jean-Michel RIUS, et al. Appln. No.: 10/536,902 Group Art Unit: 1792 Confirmation No.: 4716 Examiner: Joseph Albert MILLER JR Filed: May 27, 2005 METHOD AND DEVICE FOR MICROWAVE PLASMA DEPOSITION OF A For: COATING ON A THERMOPLASTIC CONTAINER SURFACE AMENDMENT UNDER 37 C.F.R. § 1.114(c) MAIL STOP RCE Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450 Sir: In response to the Office Action dated February 19, 2009, please amend the aboveidentified application as follows on the accompanying pages. TABLE OF CONTENTS AMENDMENTS TO THE CLAIMS......2

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